

**S/N 09/945,535**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Kie Y. Ahn et al. Examiner: Colleen E. Rodgers  
Serial No.: 09/945,535 Group Art Unit: 2813  
Filed: August 30, 2001 Docket: 1303.026US1  
Title: HIGHLY RELIABLE AMORPHOUS HIGH-K GATE OXIDE ZRO2

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**COMMUNICATION CONCERNING RELATED APPLICATIONS**

**MS AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related applications in the above-identified patent application:

| <u>Serial/Patent No.</u> | <u>Filing Date/Issue Date</u> | <u>Attorney Docket</u> | <u>Title</u>                                    |
|--------------------------|-------------------------------|------------------------|---|
| 11/737,460               | April 19, 2007                | 1303.135US2            | ALD OF AMORPHOUS LANTHANIDE<br>DOPED TiOX FILMS |
| 11/735,247               | April 13, 2007                | 1303.127US2            | HAFNIUM TANTALUM OXIDE<br>DIELECTRICS           |

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,

KIE Y. AHN ET AL.

By Applicants' Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
P.O. Box 2938  
Minneapolis, MN 55402  
(612) 349-9587

Date

9 July '07

By



Timothy B. Clise

Reg. No. 40,957

**CERTIFICATE UNDER 37 CFR 1.8:** The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 9 day of July, 2007.

Name

Lisa Pasorke

Signature

Sis Pasorke